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7-1-02 PATENT
Customer No. 22,852
Attorney Docket No. 07942.0007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Neal KUO

Serial No.: 09/900,165

Group Art Unit: 2825

Filed: July 9, 2001

Examiner: Not yet assigned

For: **METHOD AND SYSTEM FOR
DETERMINING THE BEST
INTEGRAL PROCESS PATH TO
PROCESS SEMICONDUCTOR
PRODUCTS TO IMPROVE YIELD**

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

PRELIMINARY AMENDMENT

Applicant respectfully requests that prior to examination of this application, kindly amend the subject application as follows:

IN THE DRAWINGS:

Subject to the approval of the Examiner, please add Figure 5, as proposed in the accompanying Request for Approval of Drawing Change.

REMARKS

Entry of these amendments is respectfully requested.

By the present amendment, Applicant has added Figure 5 for the purpose of illustrating the flow chart of a method according to the present invention, as set forth, for

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